



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hideki KOMATSUDA

Application No.: 09/697,639

Filed: October 27, 2000

For: EXPOSURE APPARATUS AND METHOD OF FABRICATING A MICRO DEVICE  
USING THE EXPOSURE APPARATUS

Group Art Unit: 2851

Examiner: R. Fuller

Docket No.: 105193.01

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**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant hereby requests continued examination and entry and consideration of the attached submission. The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

☒ Please suspend action on this application for three months under 37 C.F.R. §1.103(c).

Attached hereto is our check no. 136418 in the amount of ☒ \$870.00 as payment of the fees set forth in 37 C.F.R. §1.17(e) and (i). The Director is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

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01 FC:1801  
02 FC:1460

740.00 DP  
130.00 DP

Respectfully submitted,

Mario A. Costantino  
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MAC/ccs

Date: November 19, 2002

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